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PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masahiro FURUSAWA et al.

Group Art Unit: 1762

Application No.: 10/028,712

Examiner: W. Markham

Filed: December 28, 2001

Docket No.: 111604

For: A METHOD FOR FABRICATING A SILICON THIN-FILM

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

1. This Supplemental Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Notice of Allowance, but before payment of the Issue Fee. Attached to this Supplemental Information Disclosure Statement is an English language version of the Japanese language Office Action mailed on July 27, 2004. References JP-A-2000-228369 and JP-A-2000-079356 cited in the Japanese Office Action, were submitted to the Patent Office with English language Abstracts and translations on September 16, 2004. Attached to the September 16, 2004 Information Disclosure Statement was Check No. 158544 in the amount of \$180 in payment of the fee under 37 CFR §1.17(p). As such, no fee is required with this Supplemental Information Disclosure Statement; however, please credit or debit Deposit Account No. 15-0461 as needed to ensure consideration of the disclosed information.

2. The September 16, 2004 Information Disclosure Statement contained the following certification:

I hereby certify that no item of information in this Supplemental Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this Supplemental Information Disclosure Statement.  
37 CFR §1.97(e)(2).

However, this certification is in error because the information disclosed in the September 16, 2004 Information Disclosure Statement was cited in a communication from a foreign patent office. As such, it is respectfully requested the certification made in the September 16, 2004 Information Disclosure Statement be retracted and replaced with the following certification.

I hereby certify that each item of information contained in this Supplemental Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Supplemental Information Disclosure Statement.  
37 CFR §1.97(e)(1).

Respectfully submitted,



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JAO:JLC/aaw

Date: October 19, 2004

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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